

Notice of References Cited	Application/Control No. 10/765,729	Applicant(s)/Patent Under Reexamination PARKER ET AL.	
	Examiner Chen-Wen Jiang	Art Unit 3744	Page 1 of 1

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*	B	US-6,210,118 B1	04-2001	Egawa et al.	416/243
*	C	US-6,519,966 B1	02-2003	Martin, Sr., Lendell	62/324.1
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